

Title: Method to Improve Profile Control and N/P Loading in Dual Doped Gate Applications
Application No.: 10/607,612 File No.: LAM2P413
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REPLACEMENT SHEET

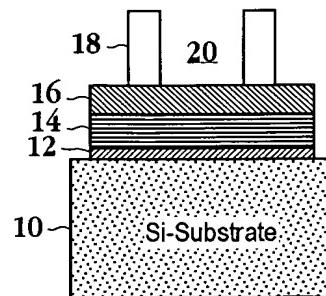


Fig. 1

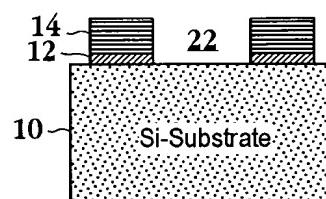


Fig. 2

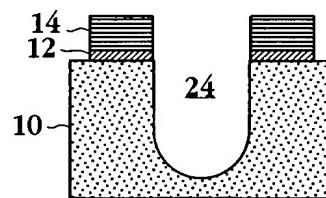


Fig. 3

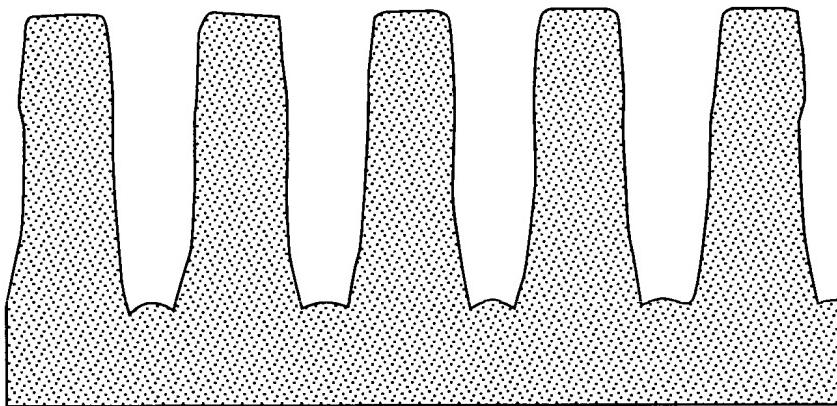


Fig. 4

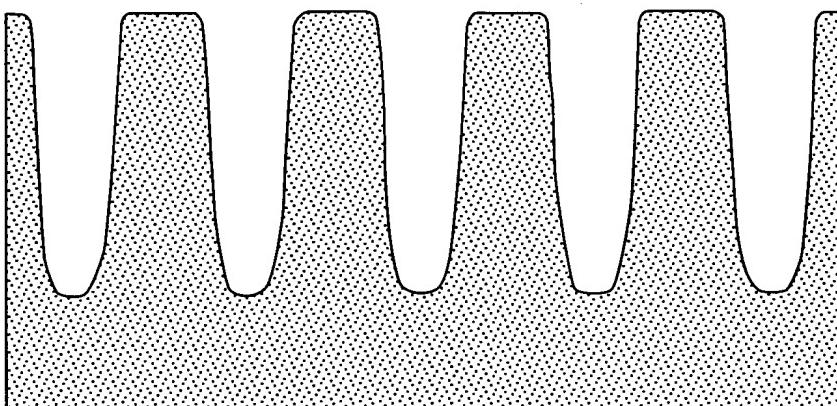


Fig. 5

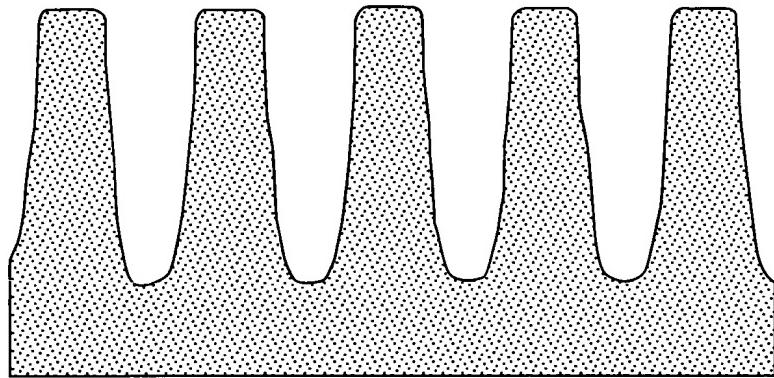


Fig. 6

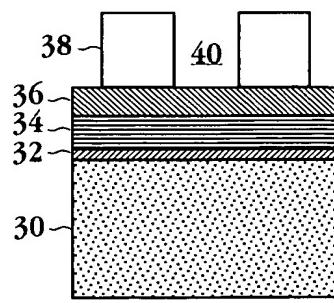


Fig. 7

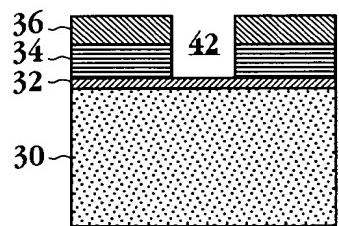


Fig. 8

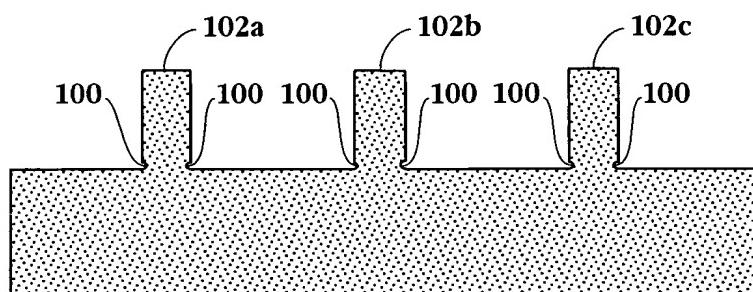


Fig. 9A

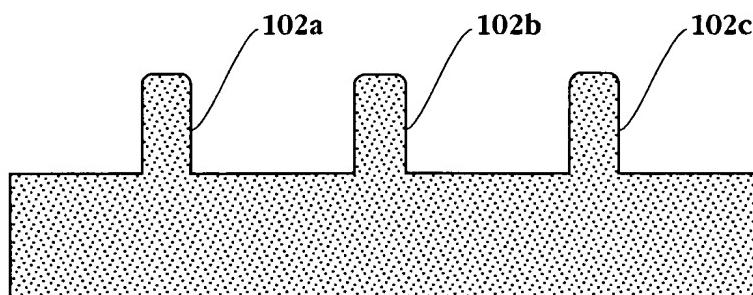


Fig. 9B

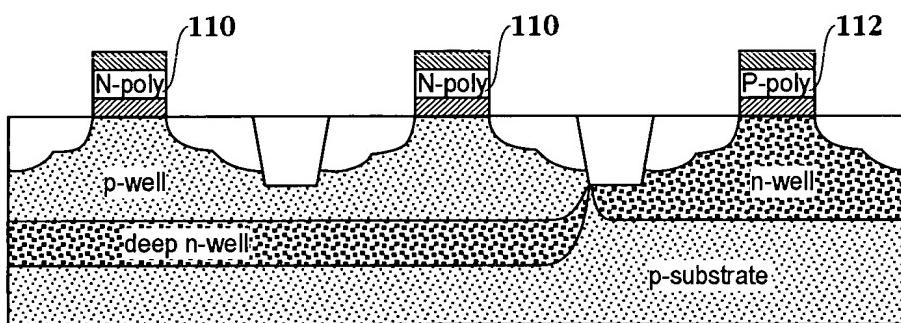


Fig. 10

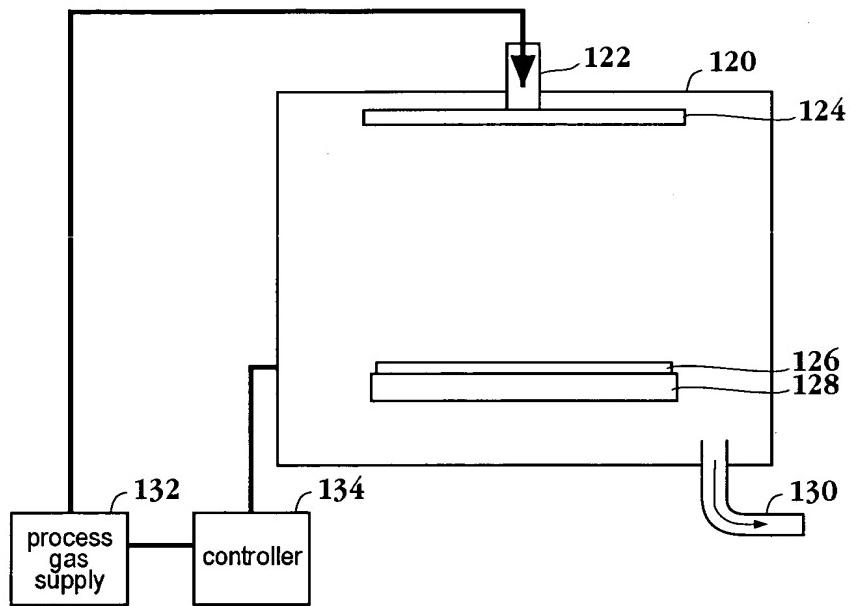


Fig. 11